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Growth and Properties of p-type Transparent Oxide Semiconductors

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Transparent oxide semiconductors (TOSs) are currently attracting attention for application to transparent electrodes in optoelectronic devices and active channel layers in thin-film transistors. One of the key issues for the realization of next generation transparent electronic devices such as transparent complementary metal-oxide-semiconductor thin-film transistors (CMOS TFTs), transparent wall light, sensors, and transparent solar cell is to develop p-type TOSs. In this talks, I will introduce issues and status related to p-type TOSs such as LnCuOQ (Ln=lanthanide, Q=S, Se), SrCu_2O_2 , CuMO_2 (M=Al, Ga, Cr, In), ZnO, Cu_2O and SnO. The growth and properties of SnO and Cu-based oxides and their application to electronic devices will be discussed.

Keywords: Transparent oxide semiconductors, SnO, Cu-based oxides, transparent electronics